



**ELECTRONIC COPY**

LG811618329  
Report verification at igi.org



June 23, 2026  
IGI Report Number **LG811618329**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **OVAL BRILLIANT**  
Measurements **11.17 X 7.19 X 4.51 MM**  
**GRADING RESULTS**  
Carat Weight **2.35 CARATS**  
Color Grade **F**  
Clarity Grade **VVS 2**

June 23, 2026  
IGI Report Number **LG811618329**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **OVAL BRILLIANT**  
Measurements **11.17 X 7.19 X 4.51 MM**

**GRADING RESULTS**

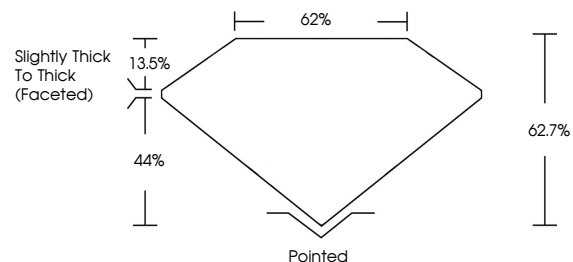
Carat Weight **2.35 CARATS**  
Color Grade **F**  
Clarity Grade **VVS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG811618329**

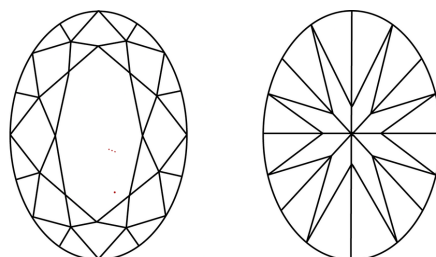
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

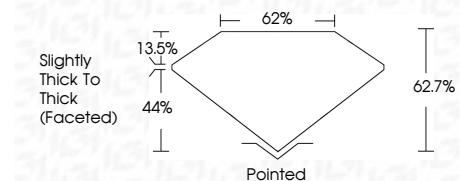
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG811618329**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa



**IGI**



June 23, 2026  
IGI Report No LG811618329  
**OVAL BRILLIANT**  
11.17 X 7.19 X 4.51 MM  
2.35 CARATS  
Color Grade **F**  
Clarity Grade **VVS 2**  
Depth **62.7%**  
Table **62%**  
Girdle **Slightly Thick To Thick (Faceted)**  
Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG811618329**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa